



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Method for H₂ Recycling In Semiconductor Processing System
Serial No.: 09/828,518 Filing Date: April 6, 2001
Examiner: Olivia T. Luk Group Art Unit: 2812
Docket No.: M-8608US

Irvine, California
August 21, 2002

BOX AMENDMENT
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

CHANGE OF CORRESPONDENCE ADDRESS

Dear Sir:

Please direct all correspondence in the above-identified application and with respect to any patent that issues on this application to the undersigned at this address:

MacPherson Kwok Chen & Heid LLP
1762 Technology Drive
Suite 226
San Jose, California 95110
Telephone No. (949) 752-7040
Fax No. (408) 392-9262

Please telephone the undersigned at (949) 752-7040 if there are any questions.

Express Mail Label No.:

EV 252 520 917 US

Respectfully submitted,

Theodore P. Lopez
Attorney for Applicant(s)
Reg. No. 44,881

LAW OFFICES OF
MACPHERSON, KWOK CHEN
& HEID LLP

2402 MICHELSON DRIVE
SUITE 210
IRVINE, CA 92612
(949) 752-7040
FAX (949) 752-7049